



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:

Jae Suk LEE

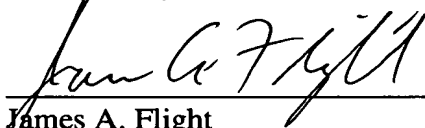
Serial No.: 10/712,945

For: METAL LINE  
STRUCTURES IN  
SEMICONDUCTOR DEVICES  
AND METHODS OF FORMING  
THE SAME

Filed: November 13, 2003

Group Art Unit: 2811

Examiner: Andrew Owens Arena

) I hereby certify that this paper is  
) being deposited with the United  
) States Postal Service as first-class  
) mail, postage prepaid, in an  
) envelope addressed to: Mail Stop  
) Amendment, Commissioner for  
) Patents  
) P.O. Box 1450  
) Alexandria, VA 22313-1450, on  
) this date:  
) **October 31, 2005**  
)  
)   
) James A. Flight  
) Registration No. 37,622  
) Attorney for Applicants

**RESPONSE TO THE OFFICE ACTION DATED JUNE 29, 2005**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office action dated June 29, 2005, please enter the following amendments and consider the following remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**The Status of the Claims** is reflected in the listing of claims that begins on page 3 of this paper.

**Remarks** begin on page 6 of this paper.